

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination OGAWA ET AL.	
		Examiner Peter Y. Choi	Art Unit 1794	Page 1 of 1

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*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B US-4,719,045	01-1988	Ogawa et al.	252/609
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L	US-			
M	US-			

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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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